

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention	FORMING A SUBSTANTIALLY PLANAR UPPER SURFACE AT THE OUTER EDGE OF A SEMICONDUCTOR TOPOGRAPHY
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Application Number: 10/662636



Confirmation Number: 9393

First Named Applicant: Venuka Jayatilaka

Attorney Docket Number: 5298-04301

Search string: (5783482 or 6472291 or 6376363 or 5918139
or 4193226 or 4811522 or 5421769 or 6010964
or 6091130 or 6020639).pn.

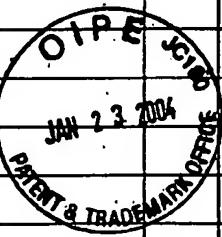
US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
9/6	1	5783482	1998-07-21	Lee et al.	X	438	624
9/8	2	6472291	2002-10-29	Page et al.		438	424
9/8	3	6376363	2002-04-23	Iguchi		439	633
9/8	4	5918139	1999-06-29	Mitani et al.		438	459
9/8	5	4193226	1980-03-18	Gill, Jr. et al.		451	276
9/8	6	4811522	1989-03-14	Gill, Jr.		451	285
9/8	7	5421769	1995-06-06	Schultz et al.		451	285
9/8	8	6010964	2000-01-04	Glass		156	345.12
9/8	9	6091130	2000-07-18	Oyamatsu et al.		257	618
9/8	10	6020639	2000-02-01	Ulrich et al.	X	257	735

Signature

Examiner Name	Date
William M. Brewster	17 APR 06

Form PTO-1449 (modified) List of Patents and Publications For Applicant's Information Disclosure Statement (Use several sheets if necessary)			ATTY. DKT. NO. 5298-04301 APPLICANT: Jayatilaka et al. FILING DATE: September 15, 2003			SERIAL NO. 10/662,636 GROUP: 1765		
U.S. PATENT DOCUMENTS								
EXAM. INITIALS	REF. DES.	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE	
								
								
FOREIGN PATENT DOCUMENTS								
EXAM. INITIALS	REF. DES.	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION YES/NO	
								
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)								
9VB	A1	Malkoe et al., "Effect of Retaining Ring System on the Polishing of 300 mm Oxide Wafers," March 2001, pp. 519-522.						
9VB	A2	Wolf, <u>Silicon Processing for the VLSI Era, Volume 2: Process Integration</u> , © 1990 by Lattice Press, pp. 238, 239.						

EXAMINER: William M. Brewster

DATE CONSIDERED: 17 APR 86

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the patent owner.